

United States Patent

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6. A method for sanitizing an enclosed structure having an exterior and an interior, comprising the steps of:

preparing said enclosed structure for exposure to a high temperature gas by removing or protecting all heat sensitive items;

disposing a plurality of temperature indicating probes at predetermined locations within said enclosed structure;

heating a gas to a predetermined temperature;

directing said heated gas into said enclosed structure in order to raise the temperature within said enclosed structure to said predetermined temperature;

monitoring the temperature detected from said probes in real time to ensure that all portions of said enclosed structure reach said predetermined temperature;

venting said heated gas from said enclosed structure; and

filtering said heated gas vented from said enclosed structure.